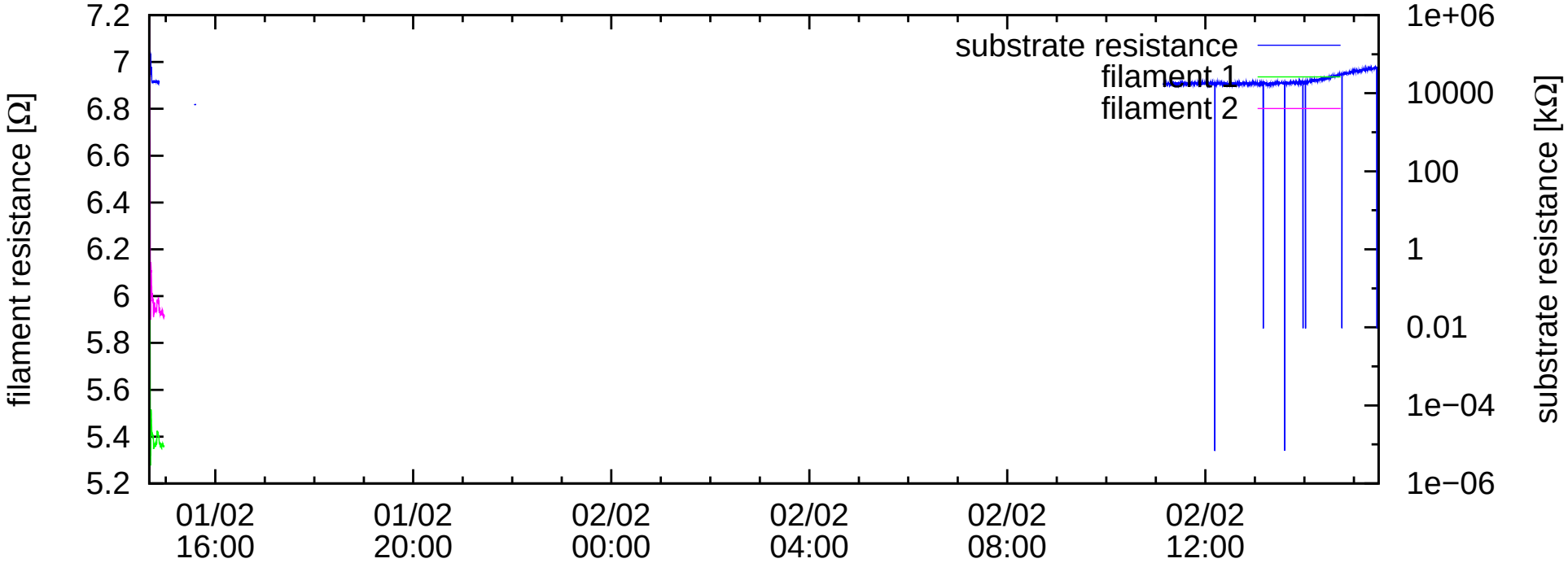
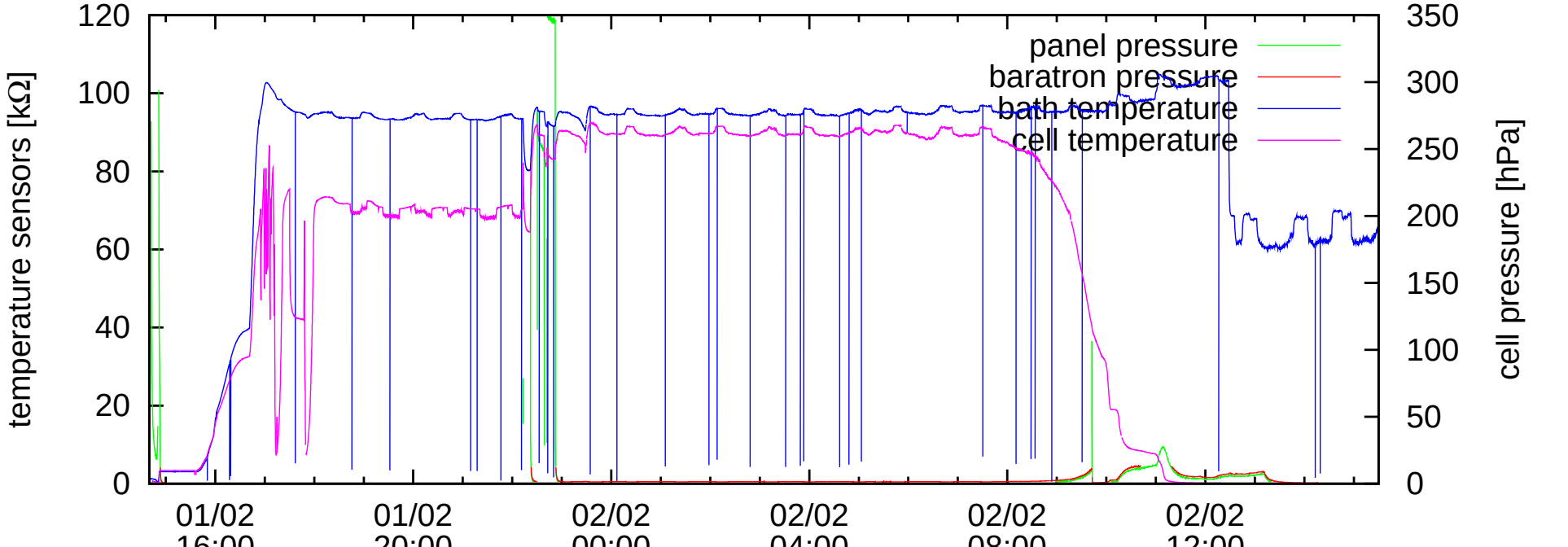

substrate resistance
filament 1
filament 2
filament resistance [Ω]
substrate resistance [kΩ]
7.2
7
6.8
6.6
6.4
6.2
6
5.8
5.6
5.4
5.2
1e+06
10000
100
1
0.01
1e−04
1e−06
01/02 16:00
01/02 20:00
02/02 00:00
02/02 04:00
02/02 08:00
02/02 12:00


panel pressure
baratron pressure
bath temperature
cell temperature
temperature sensors [kΩ]
cell pressure [hPa]
120
100
80
60
40
20
0
350
300
250
200
150
100
50
0
01/02 16:00
01/02 20:00
02/02 00:00
02/02 04:00
02/02 08:00
02/02 12:00